

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
Keiji Ishibashi) Group: Unknown
Serial No. Unknown)
Filed: August 4, 2000) Examiner: Unknown
Title: A HOT ELEMENT CVD APPARATUS)
AND A METHOD FOR REMOVING) Customer No. 00832
A DEPOSITED FILM)

D/A
CT
11/15/00

PRELIMINARY AMENDMENT

Box Patent Application
Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Prior to the examination of the above-identified application, please amend the application as follows:

IN THE TITLE

Delete the title and substitute therefor --A HOT ELEMENT CVD APPARATUS AND A METHOD FOR REMOVING A DEPOSITED FILM--.

IN THE ABSTRACT

Delete the Abstract and substitute therefor the Abstract attached hereto as a separate sheet.

IN THE SPECIFICATION

Please cancel the specification and replace it with the substitute specification submitted herewith. Also submitted for the Examiner's convenience is a copy of the original specification which shows deleted material with a line through it and added material underlined. In accordance with the requirements of 37 CFR § 1.125(b), the undersigned submits that the substitute specification includes no new matter.

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